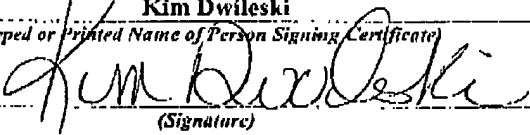


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| Applicant(s): Cline et al. | | |
| Application No. 10/711,953 | Filing Date 10/15/2004 | Examiner Chen, Eric Brice |
| | | Group Art Unit 1765 |
| Invention: DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION | | |
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cline *et al.*

Examiner: Chen, Eric Brice

Serial No.: 10/711,953

Art Unit: 1765

Filed: 10/15/2004

Docket No.: BUR920040122US1

Title: **DEEP TRENCH FORMATION IN SEMICONDUCTOR DEVICE FABRICATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR RECONSIDERATION

Sir:

This Request for Reconsideration is in response to the Final Office Action mailed
January 26, 2006.

10/711,953

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